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3-18-07

**RESPONSE UNDER 37 C.F.R. § 1.116**  
**EXPEDITED PROCEDURE – Art Unit 1762**  
Attorney Docket No. 108298722US  
Disclosure No. 02-1565.00/US

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: DEMETRIUS  
SARIGIANNIS *ET AL.*

APPLICATION No.: 10/665,908

FILED: SEPTEMBER 18, 2003

FOR: **SYSTEMS AND METHODS FOR  
DEPOSITING MATERIAL ONTO  
MICROFEATURE WORKPIECES IN  
REACTION CHAMBERS**

EXAMINER: KELLY M. STOUFFER

ART UNIT: 1762

CONF. NO: 7052

**Amendment Under 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated December 27, 2006 in the above-identified application. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.